



6-9-05

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PATENT
Case Docket No.: **NECF 18.591**
Customer No. 26304

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Takaaki Nagai** :
Serial No.: **09/837,734** :
Filed: **April 17, 2001** :
Group Art Unit: **2811** :
Examiner: **Douglas W. Owens** :
Confirmation No.: **9062** :

For: **NON-VOLATILE SEMICONDUCTOR STORAGE APPARATUS AND
MANUFACTURING METHOD THEREOF**

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 8, 2005, please enter the
following:

- I. A complete listing of the claims is presented on page two herein; and
- II. A Remarks section, presented on page seven herein.
- III. An Appendix including an Attachment A and an Attachment B

Filed Via Express Mail pursuant to 37 C.F.R. 1.10
Record No.: 61479699097 45
On: June - 8 - 05
By: [Signature]

Any fee due as a result of this paper, not covered by an
enclosed check, may be charged on Deposit Acct. No. 50-1290.